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# U.S. UTILITY Patent Application

PATENT NUMBER and  
ISSUE DATE

APPL NUM 10039357	FILING DATE 11/07/2001	CLASS 257	SUBCLASS	GAU 2811	EXAMINER <i>ZERVIGON</i>
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**\*\*CONTINUING DATA VERIFIED:**

**\*\* FOREIGN APPLICATIONS VERIFIED**  
REPUBLIC OF KOREA 2000-65873 11/07/2000

*RT 3/21/3*

PG-FUB DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority, claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	ATTORNEY DOCKET NO.
35 USC 112 conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	TJK 203-LW
Verity and Acknowledged Examiners initials <i>[Signature]</i>	
TITLE: Apparatus and method for thin film deposition	

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G.
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheets Drwg.	Figs. Drwg. Print Fig.
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		Application Examiner	
		<b>PREPARED FOR ISSUE</b>	
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